

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant :	Manish Chandhok	Art Unit:	Unknown
Serial No.:	New Application	Examiner:	Unknown
Filed :	August 25, 2003	Assignee:	Intel Corporation
Title :	LITHOGRAPHY ALIGNMENT		

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Dear Sir:

Applicants call attention to the attached Information Disclosure Statement and documents listed on form PTO-1449.

This filing is being made before the receipt of a first Office action on the merits. No fee is required.

The documents are in the English language; hence no concise explanation is necessary per Rule 98(a)(3).

Consideration of the foregoing and enclosures plus the return of a copy of the enclosed form PTO-1449 with the Examiner's initials in the left column per MPEP 609 are earnestly solicited along with an early action on the merits.

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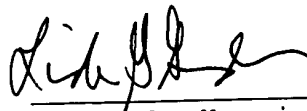
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Respectfully submitted,

Date: 8/25/03



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Substitute Form PTO-1449 (Modified) Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b)) IDS filed 8/25/2003	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 10559-839001/Intel P16714	Application No. New Application
	Applicant Manish Chandhok		
	Filing Date	Group Art Unit Unknown	

U.S. Patent Documents

Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	6,481,003 B1	11/12/2002	Maeda			
	AB	6,567,155 B1	5/20/2003	Chandhok et al.			
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

Foreign Patent Documents or Published Foreign Patent Applications

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AL							
	AM							
	AN							
	AO							
	AP							

Other Documents (include Author, Title, Date, and Place of Publication)

Examiner Initial	Desig. ID	Document
	AQ	John E. Bjorkholm, "EUV Lithography—The Successor to Optical Lithography?", Intel Technology Journal Q3'98 (John.Bjorkholm@intel.com)
	AR	
	AS	
	AT	

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	